



Docket No.: 61352-048

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Ken IDOTA, et al.	:	Confirmation Number: 5592
	:	
Serial No.: 10/695,478	:	Group Art Unit: 2811
	:	
Filed: October 29, 2003	:	Examiner: To be Assigned
	:	
For: SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREOF		

REQUEST FOR CORRECTED 111a TRANSMITTAL LETTER

Mail Stop
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a copy of the transmittal form forwarded to your office on October 29, 2003. Please noted that the residence of the third Inventor was misspelled. Enclosed is a copy of the Declaration and Power of Attorney Document, which evidences that the third inventor residence information should read: Uehonmachi, Osaka, JAPAN. Please update your records accordingly.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


Michael E. Fogarty
Registration No. 36,139

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 MEF:mcw
Facsimile: (202) 756-8087
Date: March 3, 2004



Docket No.: 61352-048

REQUEST FORM FOR CONTINUATION APPLICATION UNDER 35 USC 111(a)

Prior Application: International Application No. PCT/JP02/09569
Art Unit: (Unassigned)
Examiner: (Unassigned)

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

This is a Request for filing a continuation or continuation-in-part application, entitled SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREOF, under 35 U.S.C. 111(a) of pending prior International Application No. PCT/JP02/09569, filed on September 18, 2002, entitled SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREOF, by the following named inventor(s):

INVENTOR	RESIDENCE	CITIZENSHIP	POST OFFICE ADDRESS
Ken IDOTA	Moriguchi-shi, Osaka, JAPAN	Japanese	1-5-10-405, Toda-cho, Moriguchi-shi, Osaka 570-0014 JAPAN
Teruhito OHNISHI	Yamanouekitamachi, Osaka, JAPAN	Japanese	60-1-1202, Yamanouekitamachi, Hirakata-shi, Osaka 573-0049 JAPAN
Akira ASAI	Uchonmachi, Osaka JAPAN	Japanese	9-5-12-1303, Uchonmachi, Tennoji-ku, Osaka-shi, Osaka 543-0001 JAPAN

- ☒ I hereby verify, to the best of my knowledge, that the enclosed copy of this prior application is a true copy of the above-identified prior application, including the oath or declaration as originally filed.
- ☐ Preliminary Amendment is enclosed.
- ☒ An Information Disclosure Statement and PTO1449 Form are submitted herewith.
- ☐ Cancel claims